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# Assessing the effect of *in-situ* plasma cleaning on electrode plasma formation in a 650-kA MITL

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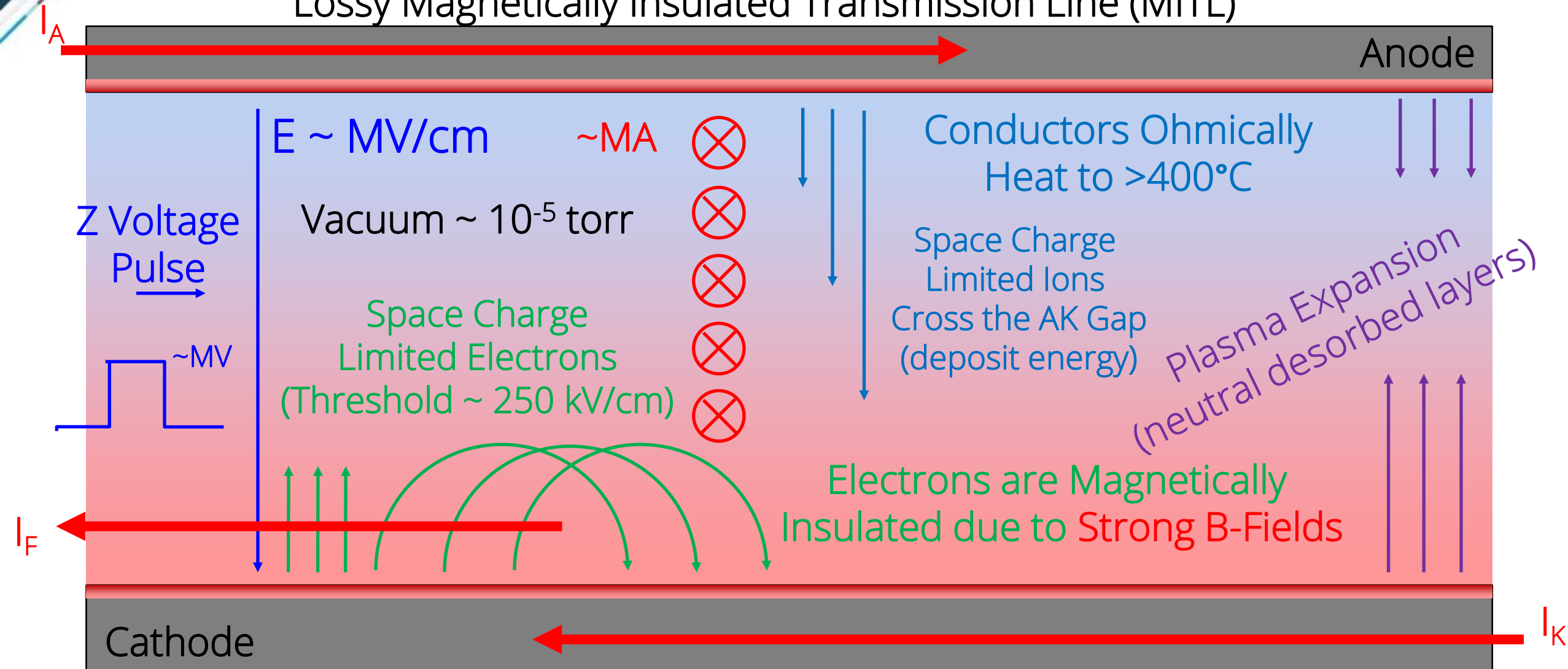
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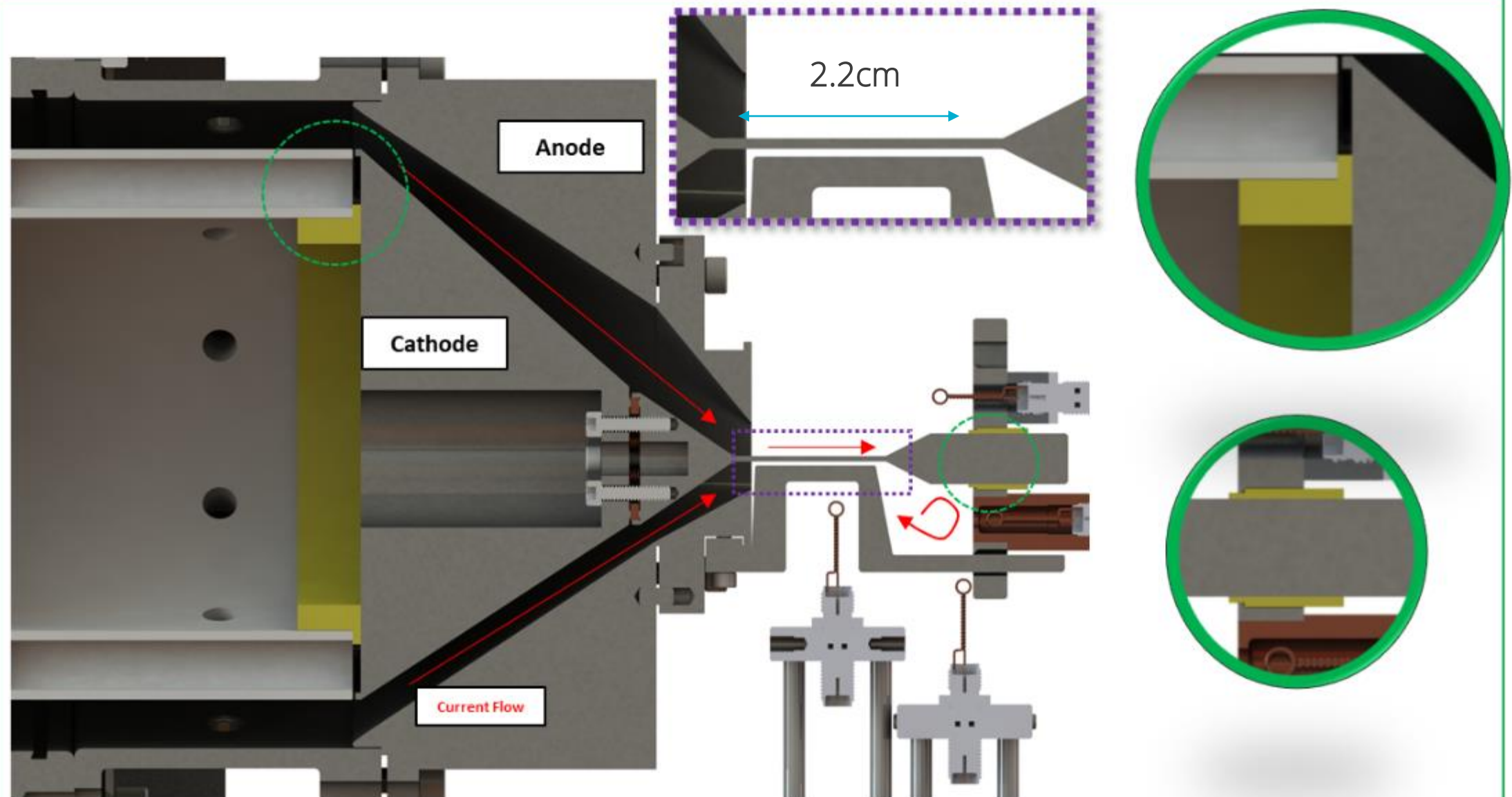
# Light ion species desorbed from electrode surface contribute to Z Machine current loss

Lossy Magnetically Insulated Transmission Line (MITL)



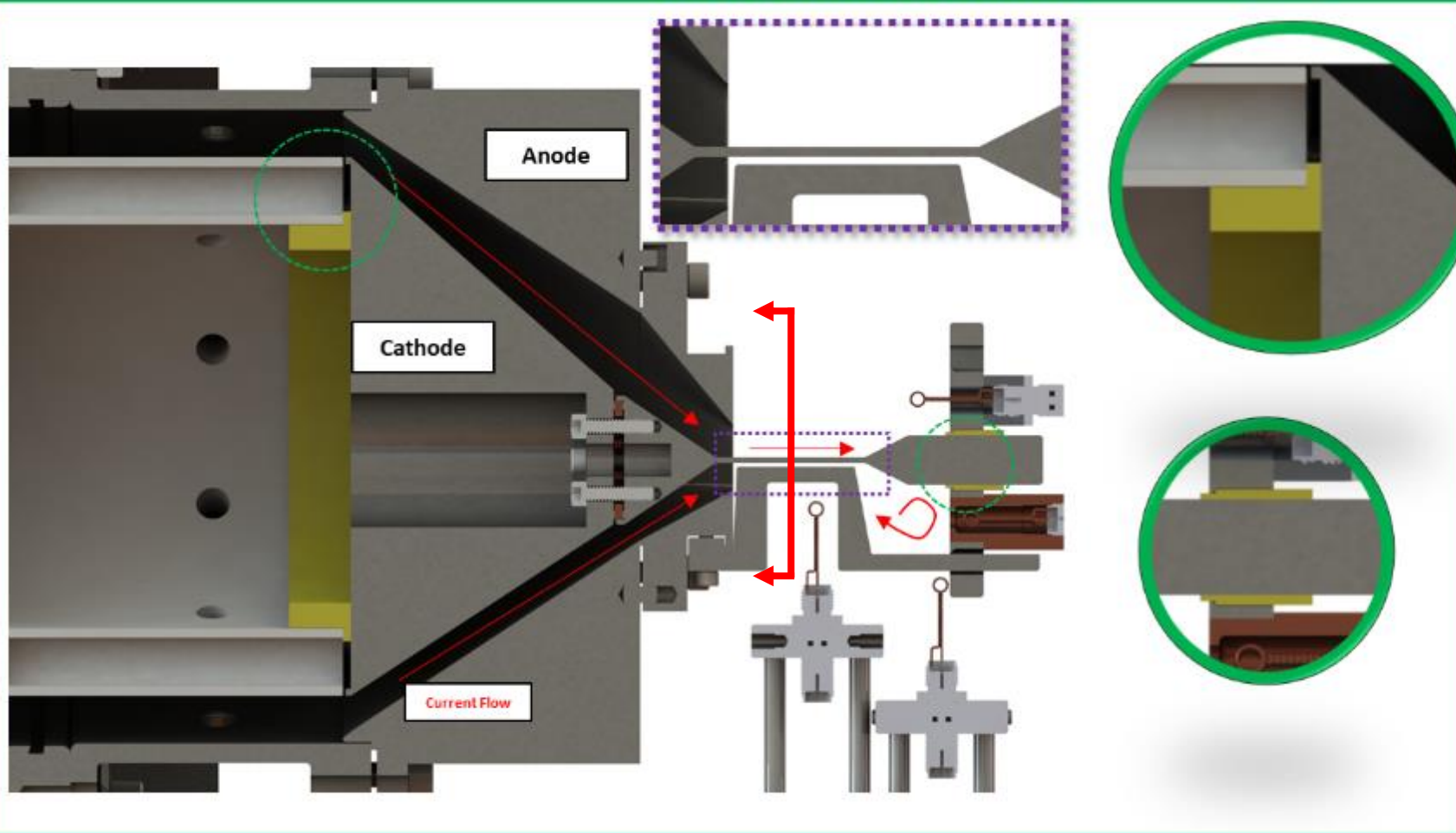


# New accelerator load allows spectroscopic and imaging access to high-field experimental MITL region



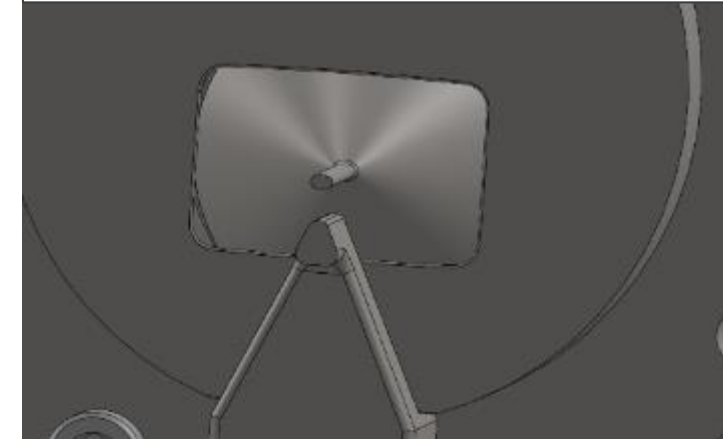


# New accelerator load allows spectroscopic and imaging access to high-field experimental MITL region

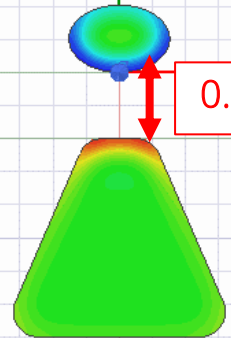
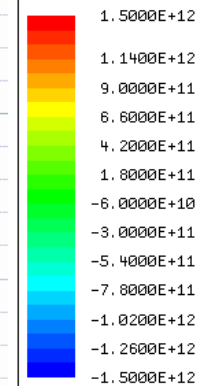


Adapting hardware modifies low-J axisymmetric current delivery into diagnosable parallel plate, high-field-stress experimental MITL region

Elliptical cathode cross-section enforces more uniform current distribution



$J$  [A/m<sup>2</sup>]



0.5-1mm

Lineal current densities  $\sim 2$  MA/cm,  
 $\Delta T > 400^\circ\text{C}$  in  $\sim 40\text{ns}$





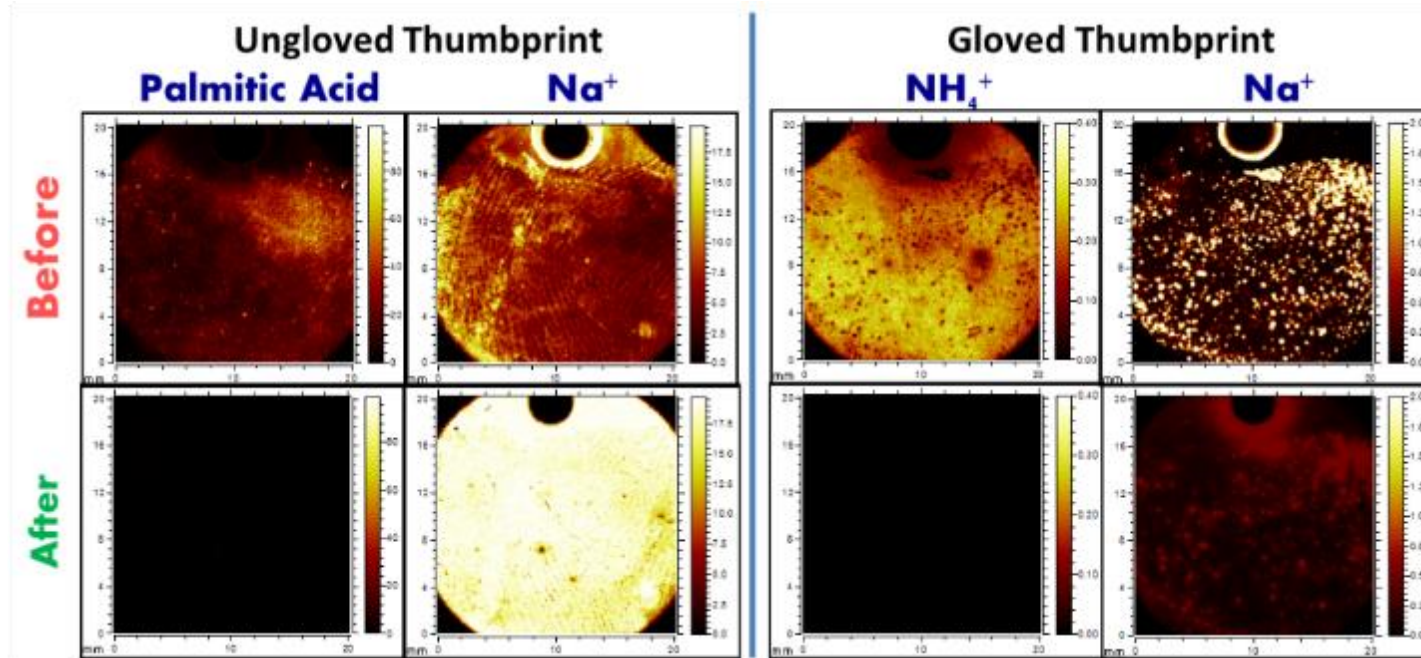
# We are using an *in-situ* plasma glow discharge to remove contamination from electrode surfaces

An 80% Argon, 20% oxygen process gas is used.

- Argon ions sputter lightly-bound contaminants into the gap ( $\text{H}_2\text{O}$ ,  $\text{H}_2$ ,  $\text{C}_x\text{H}_y$ , etc.)
- Oxygen ions chemically react with sputtered contaminants and are pumped out

We have developed an audio-frequency square wave (ASW) excitation on the accelerator electrodes themselves to ignite glow discharge

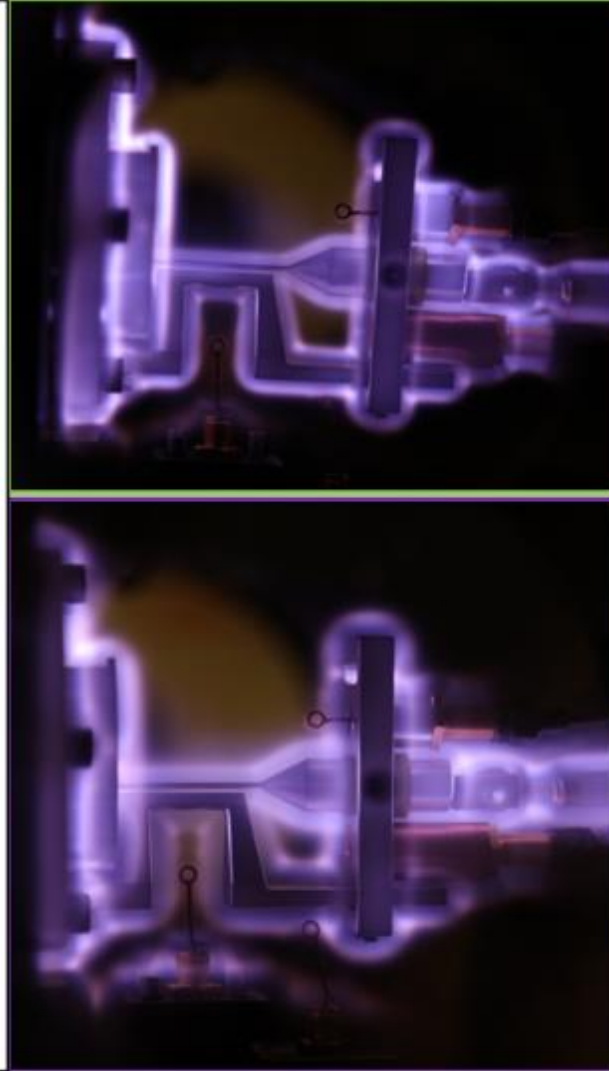
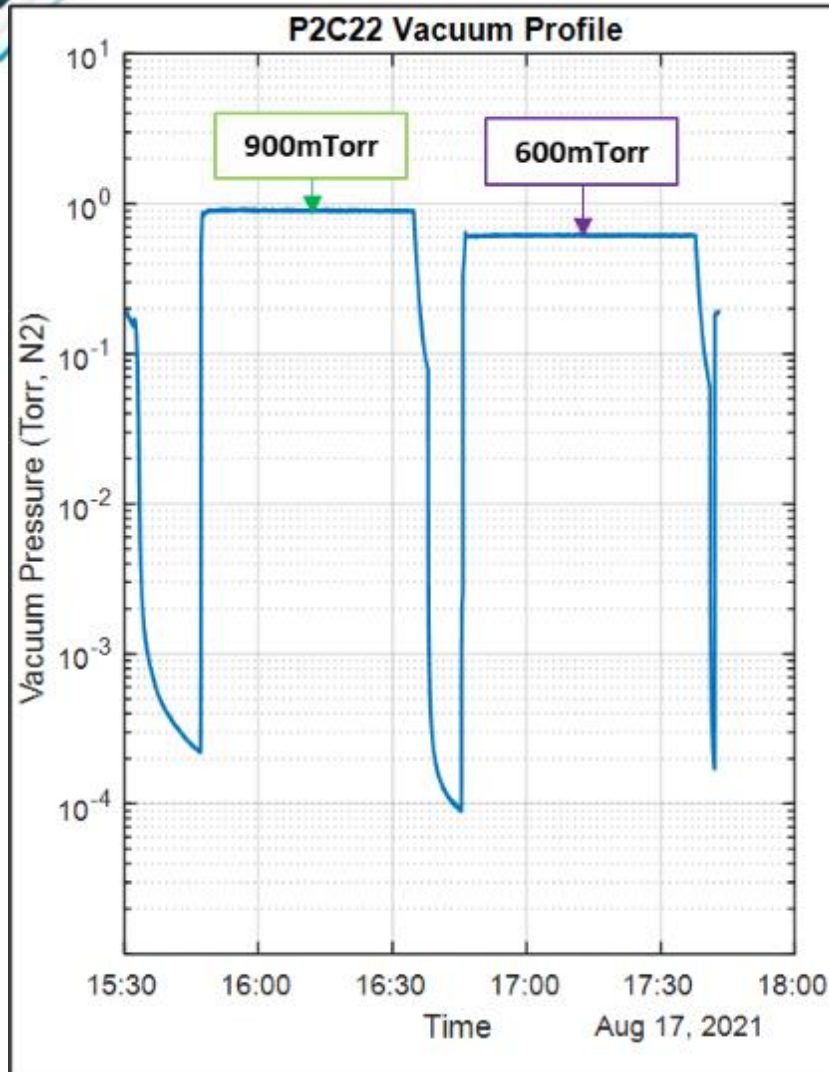
- Switching frequency ~ 10-25 kHz
- Background gas pressures ~ 0.1 – 1 Torr
- Effective AK gap cleaning ~ 0.1 - 1 cm
- +/- 1kV, up to 600W switch potential of MITL cathode
- Electrical insulators are used to localize cleaning plasma in the MITL regions with highest power density
  - Only clean the surfaces where losses occur



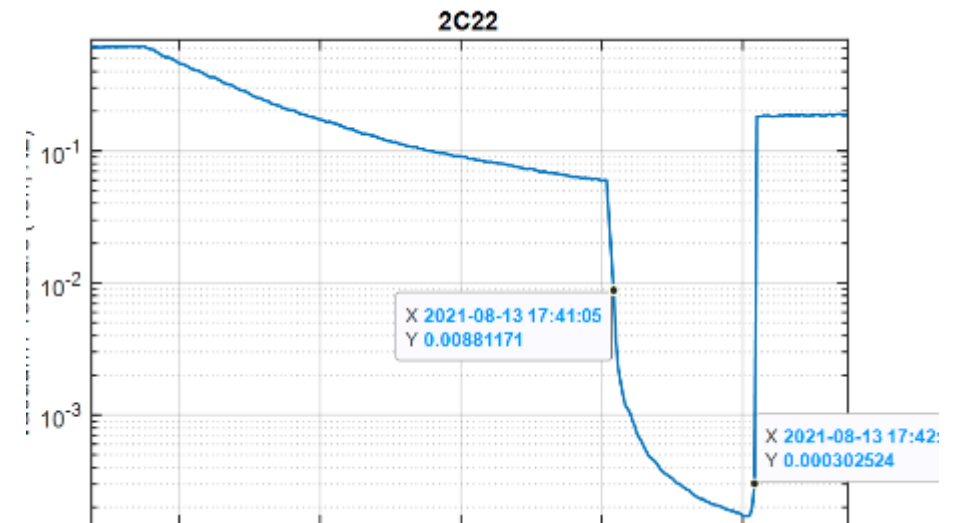
Ten minutes of argon-oxygen plasma cleaning process removes light molecules, exposes metal ions to surface-sensitive TOF-SIMS measurement technique.



# The *in-situ* cleaning process is performed under vacuum before the accelerator downline shot



- Chamber pumped to  $1\text{e-}04$  Torr
- 80/20 Ar/O<sub>2</sub> introduced to backfill to 900mTorr
- 75mA (25W) discharge for 45 min
- Pumped out.
- Refilled to 600mTorr.
- 75mA (25W) discharge for 45 min
- Stop gas flow, open gate valve, charge, fire



Machine is typically fired within 60 seconds of extinguishing plasma

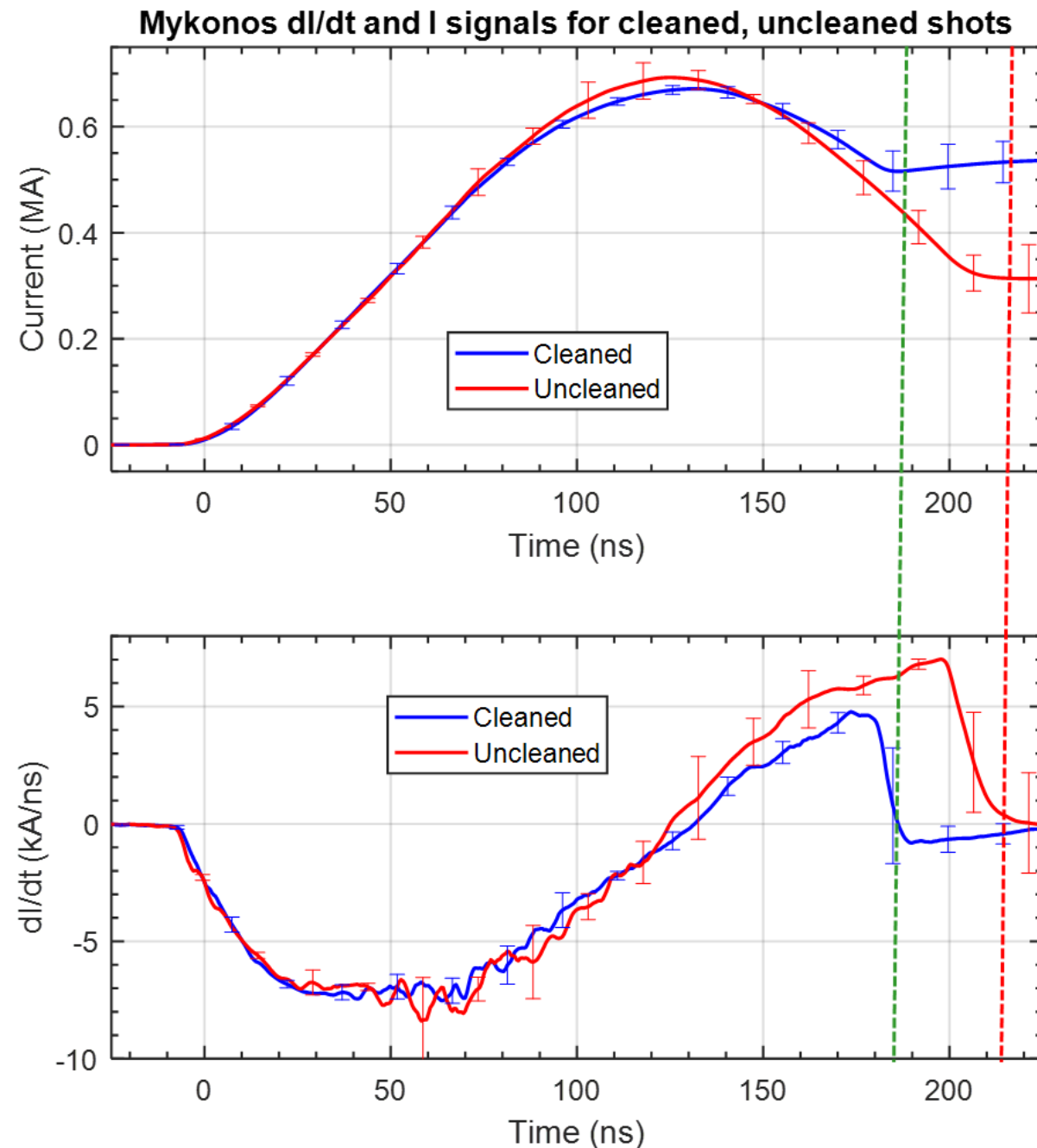


## Electrical diagnostics infer reduced electrode plasma accumulation in load region for cleaned experiments

We assert that *in-situ* cleaning delays electrode plasma turn-on and reduces accumulation of plasma densities sufficient to affect impedance

- Delayed expansion of dense electrode plasma maintains vacuum MITL impedance longer into the pulse
- Accelerator voltage reverses “on time” if the load impedance is not collapsing from this plasma effect
- Upstream water-vacuum insulator flashes over with voltage reversal, gives characteristic drop in  $dl/dt$

**We report that voltage reversal occurs ~25 ns earlier on cleaned experiments with MITL AK spacing ~ 0.75mm.**

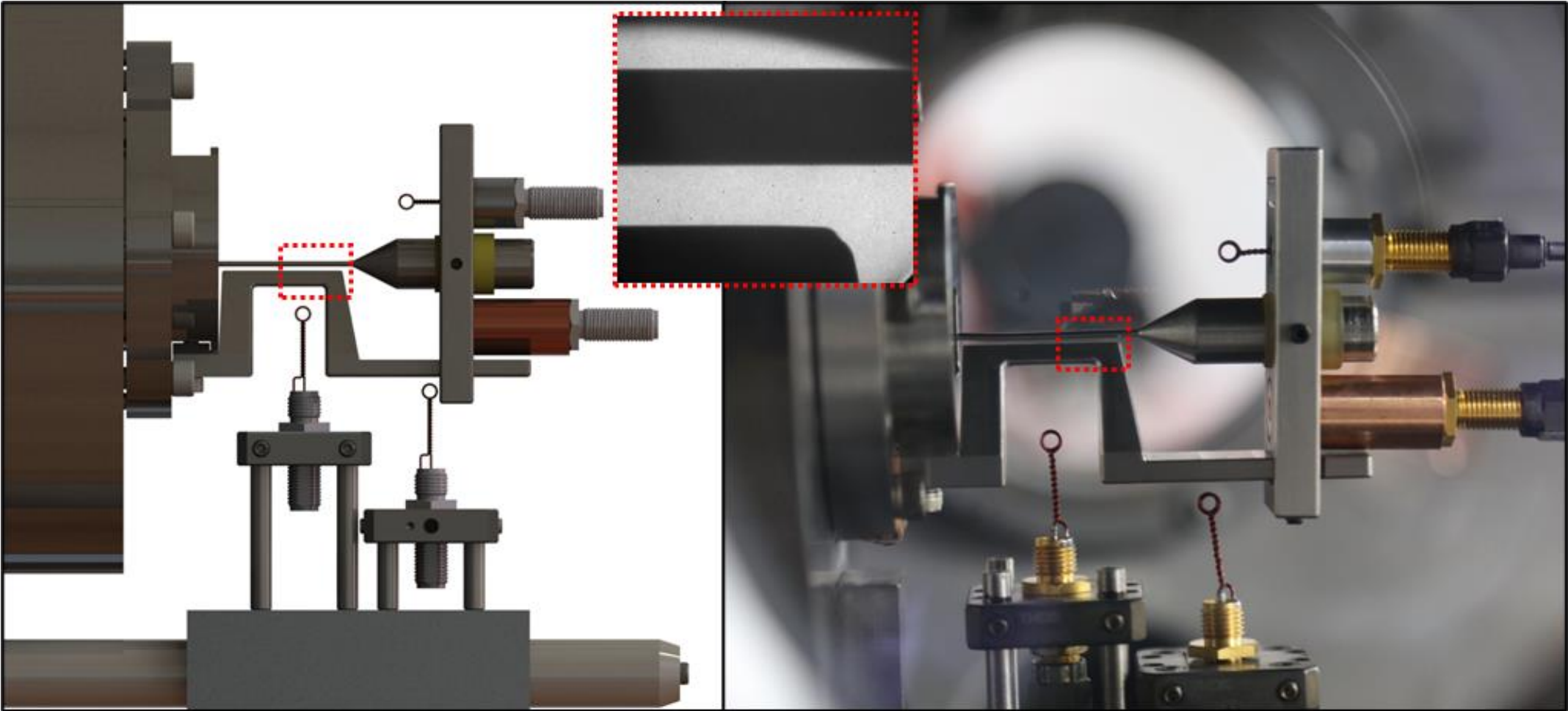


Subset of Mykonos experiments with AK spacing of 0.67-0.81mm shows ~27 ns delay from in voltage reversal “crowbarring” of load region





# Parallel plate MITL enables gated imaging system to observe self-emission from electrode plasma



Side-view of an 0.5mm AK spacing, 2.1 MA/cm experiment. **Inset is the backlit magnification-4 field of view**, for one ICCD; the cathode and the bend of the anode knee are visible. Power flows to the right in all images.

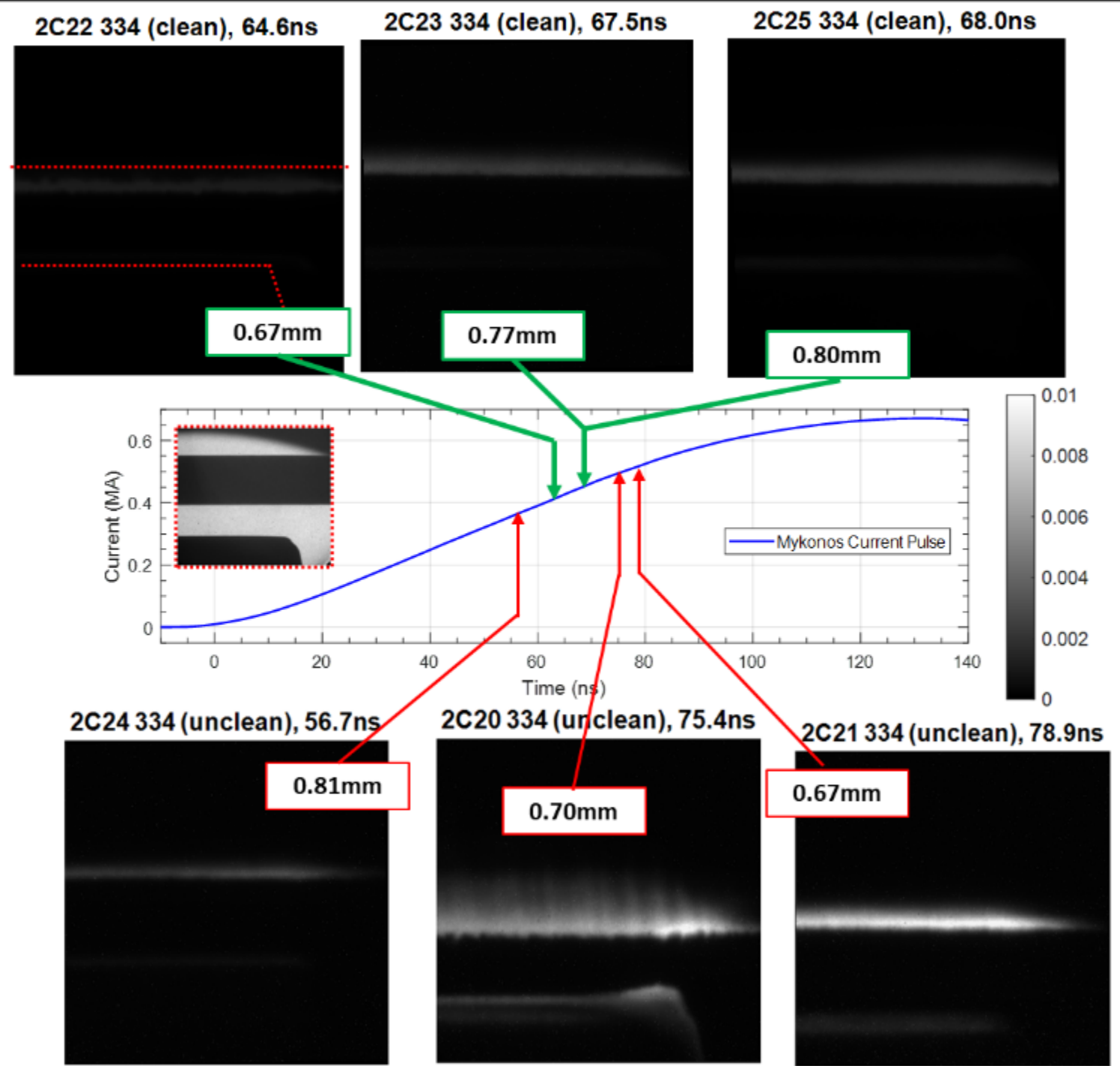




# Gated images show cleaning delays electrode plasma self emission

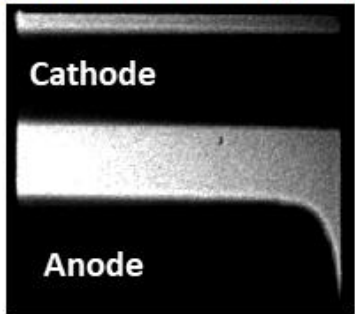
Shots with *in-situ* cleaning observe 3-5X reduction in intensity compared to uncleaned shots

- Data shown on same intensity colorbar
- Machine jitter prevented closely time-aligned comparisons between shots
- Images shown are for AK spacing ~0.7-0.8mm
- We observe strong variation in plasma formation and instability growth rates with changes in AK gap spacing



# Fast framing camera data shows *in-situ* plasma cleaning delays self emission and apparent gap closure of 0.55mm MITL AK gap

0.72mm CLEANED: Background



$\times 10^4$

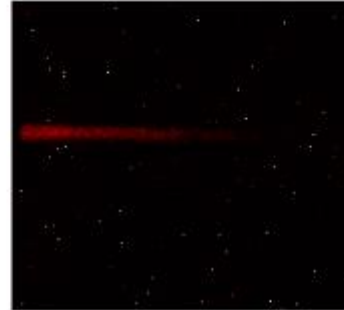


0.72mm CLEANED

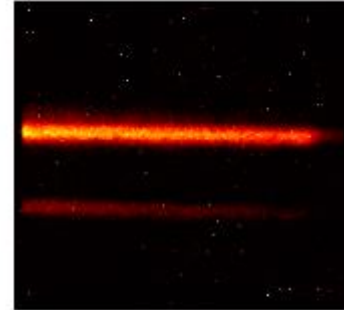
32.2 - 42.2 ns



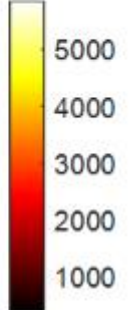
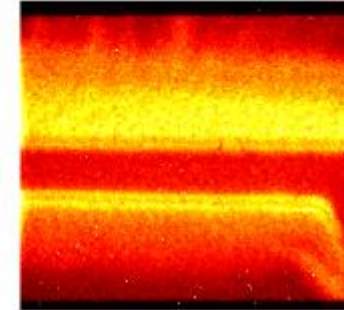
42.2 - 52.2 ns



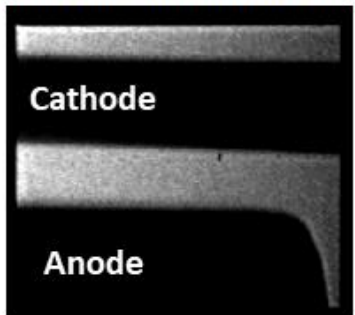
52.2 - 62.2 ns



102.2 - 112.2 ns



0.56mm CLEANED: Background



$\times 10^4$

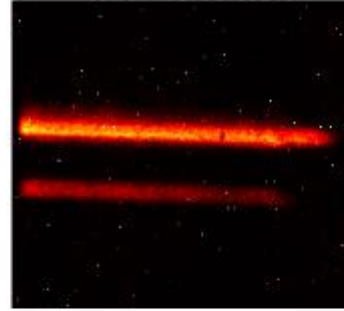


0.56mm CLEANED

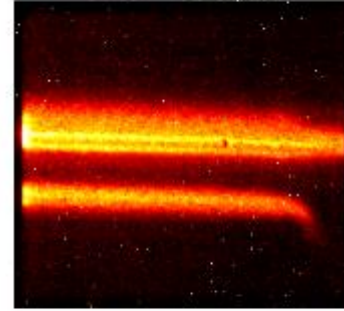
32.5 - 42.5 ns



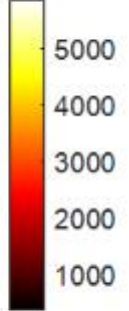
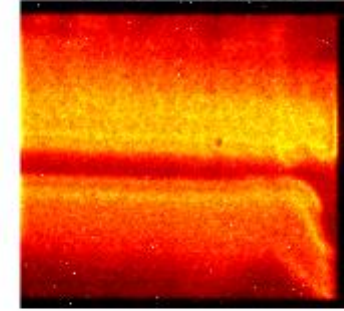
42.5 - 52.5 ns



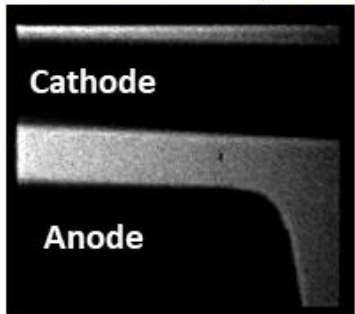
52.5 - 62.5 ns



102.5 - 112.5 ns



0.55mm DIRTY: Background



$\times 10^4$

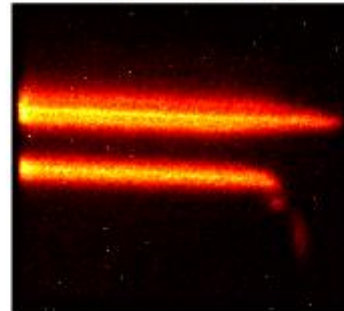


0.55mm DIRTY

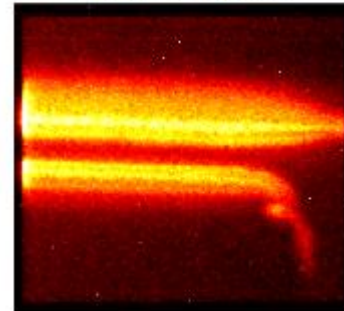
26.6 - 36.6 ns



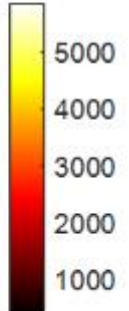
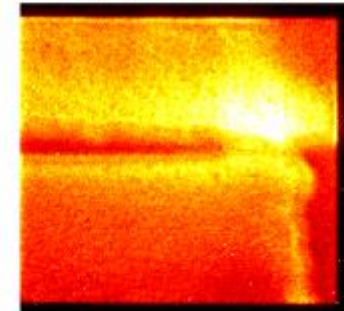
36.6 - 46.6 ns



46.6 - 56.6 ns



96.6 - 106.6 ns



12 frames, 10-ns exposure, zero interframe delay – 120ns total record length



# Filtered avalanche photodiodes observe 12-15ns delay in electrode plasma emission on cleaned experiments.

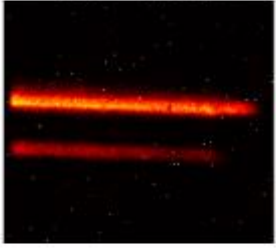
0.72mm CLEANED

42.2 - 52.2 ns



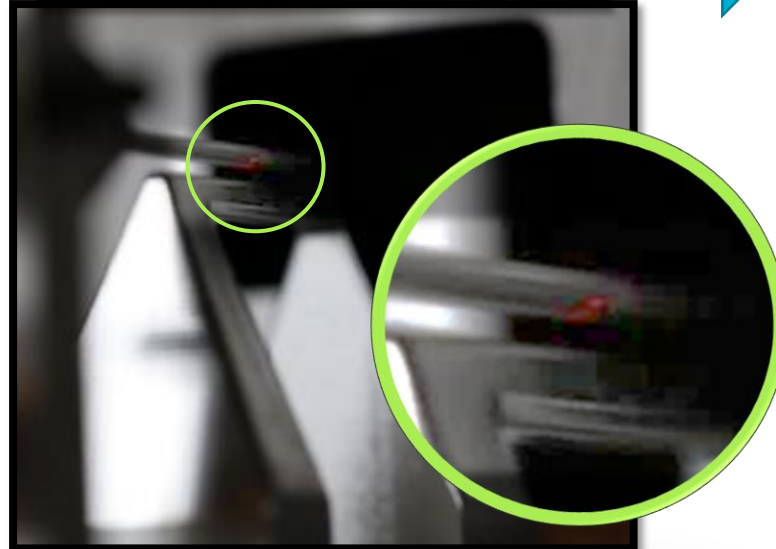
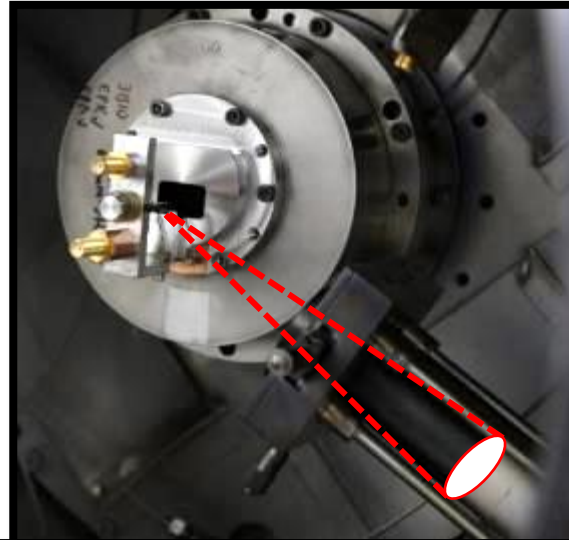
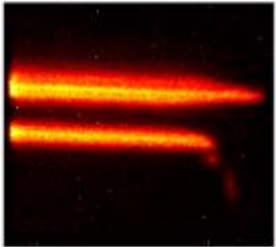
0.56mm CLEANED

42.5 - 52.5 ns



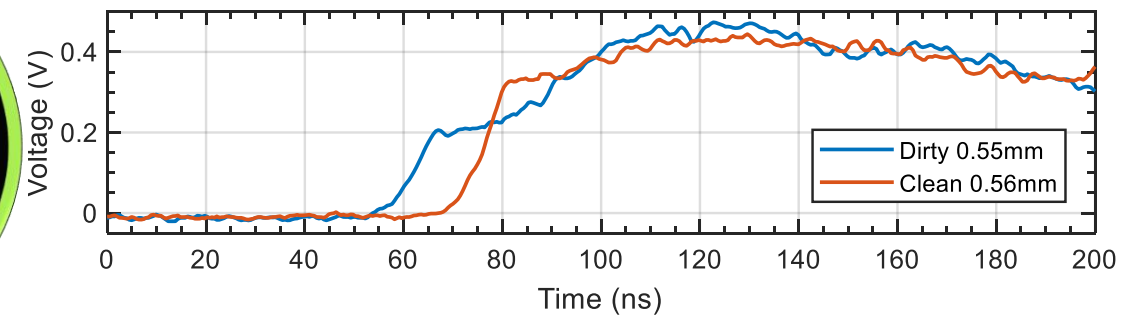
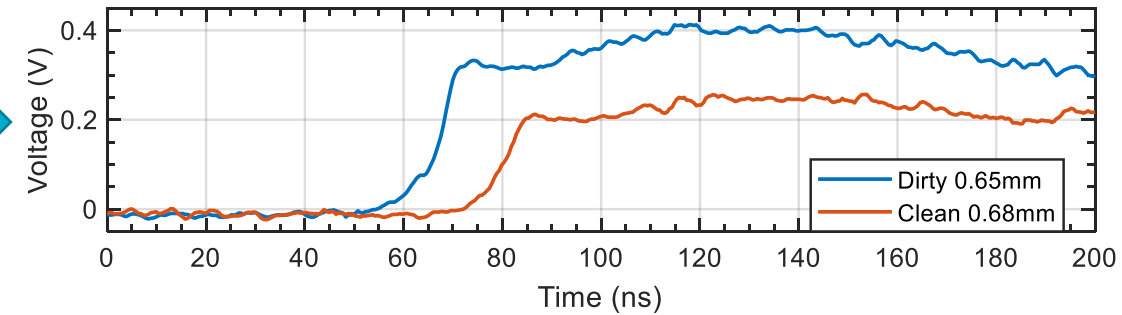
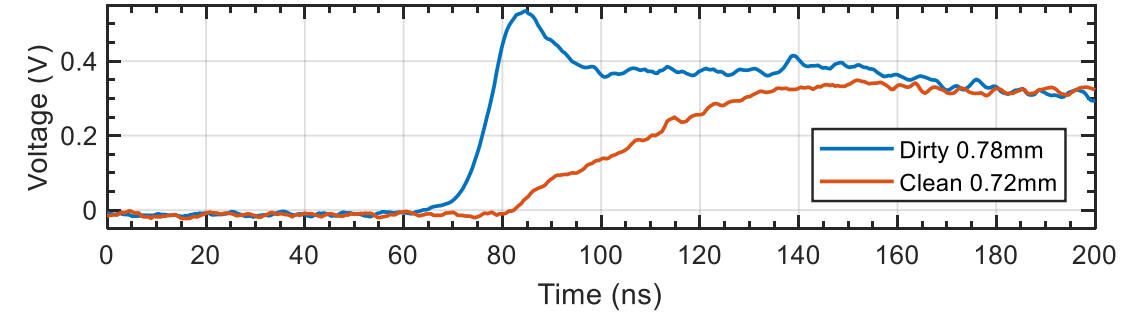
0.55mm DIRTY

36.6 - 46.6 ns



Focused optical path interrogates  
~1mm diameter spot size on cathode

Electrode plasma turn-on Comparison



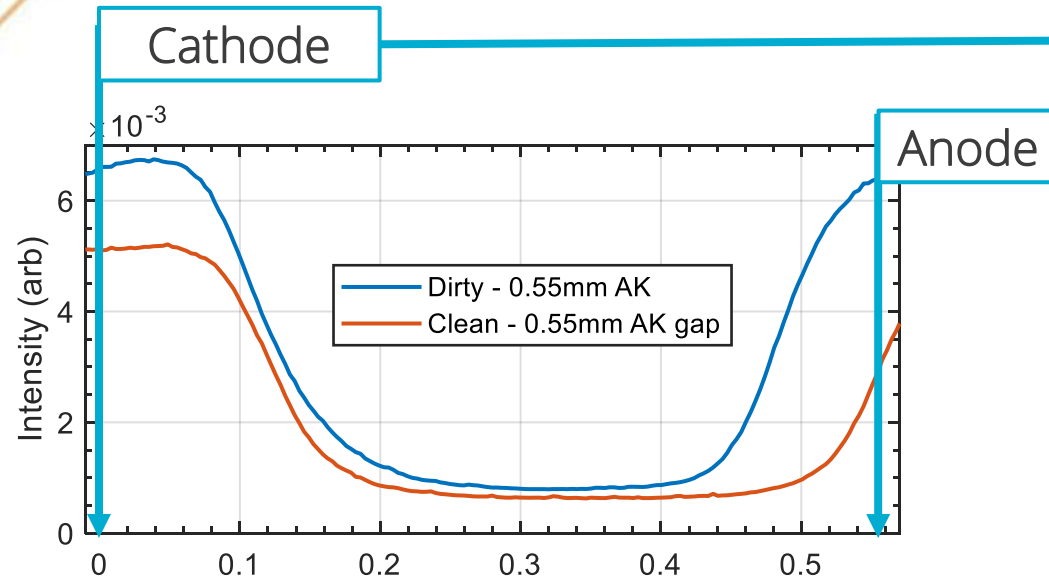
10-ns exposures result in  
ambiguous estimates of  
turn-on time ...

Cleaned shots observe 12-15 ns delay in electrode plasma  
turn-on (observable self emission within 640 +/- 5nm)  
compared to dirty shots. AK gap spacing matters.

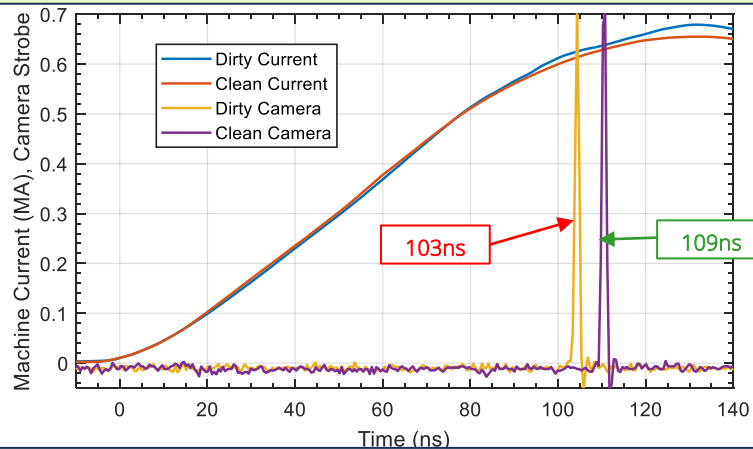




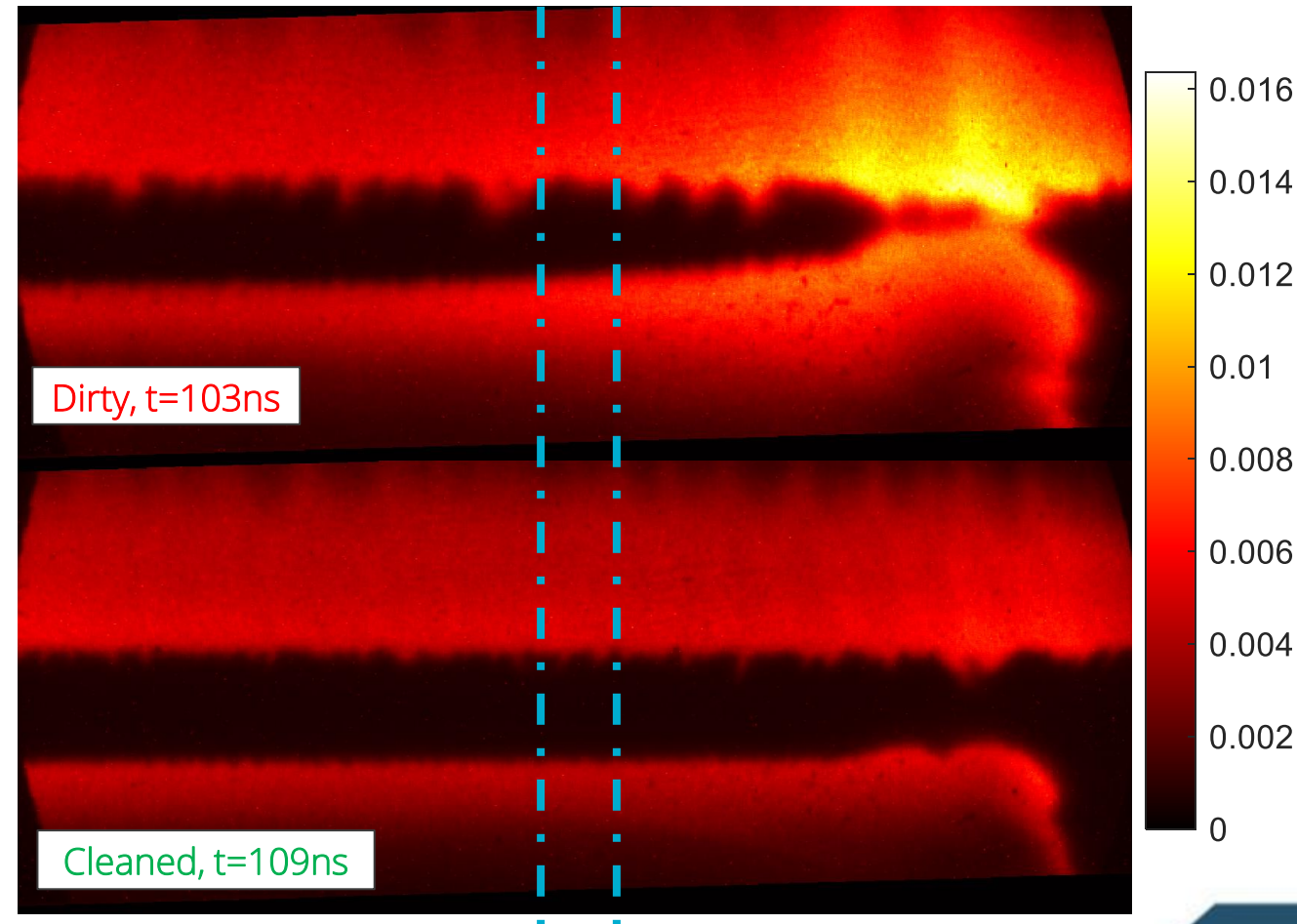
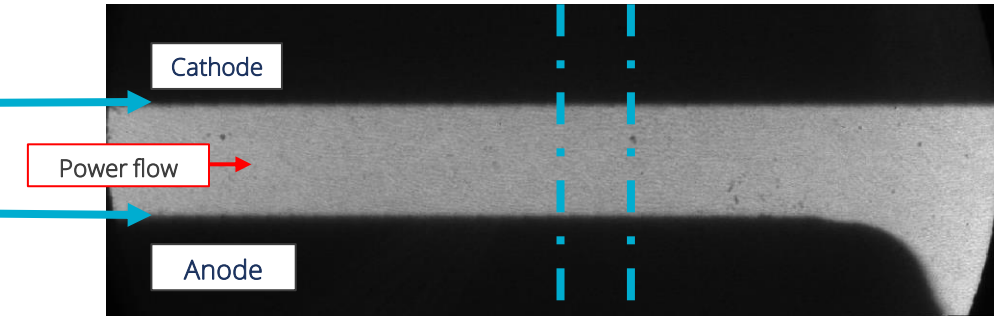
# Anode plasma expansion is delayed by plasma cleaning process



Higher intensity self emission appears earlier, further into gap on uncleaned versus cleaned shot



High-resolution, 5-ns single-frame exposures near peak current for 0.55mm AK gaps





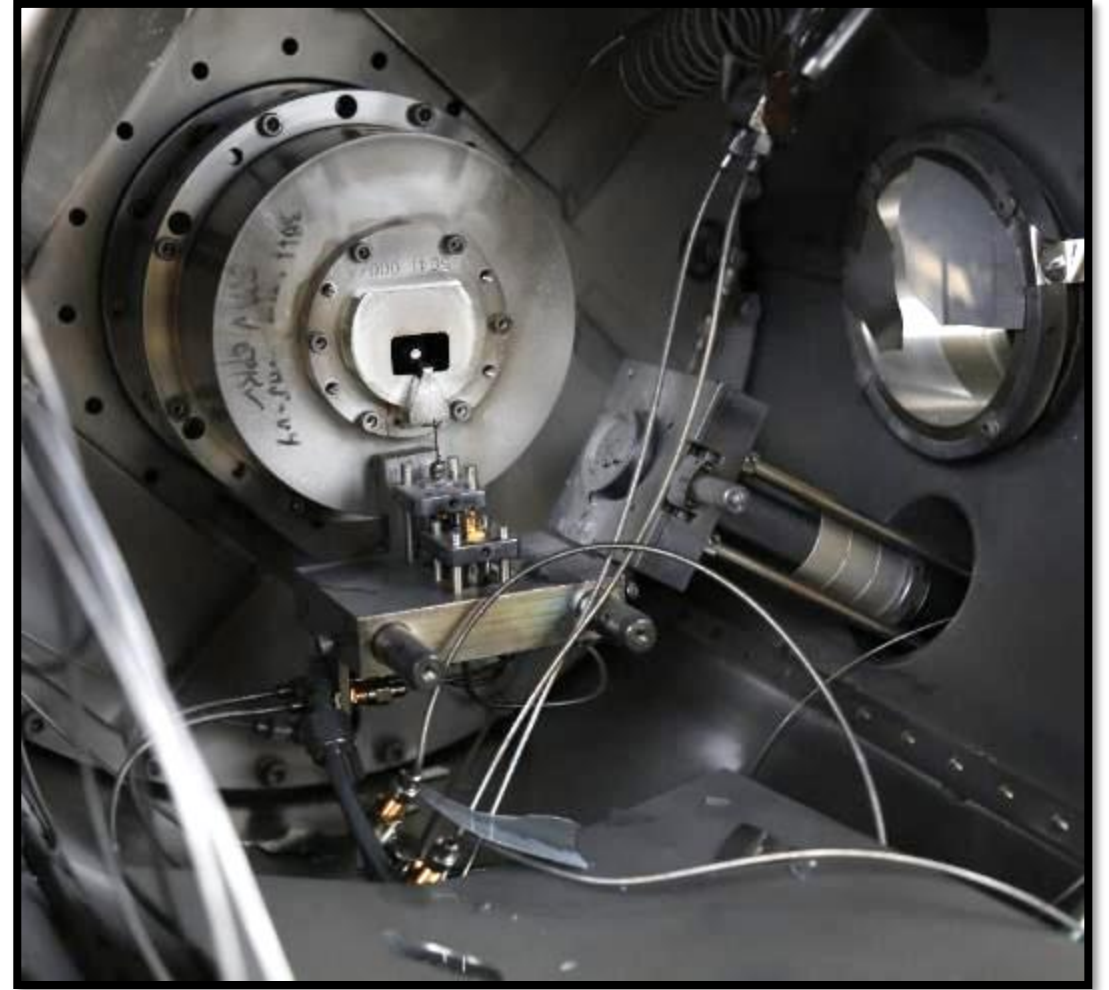
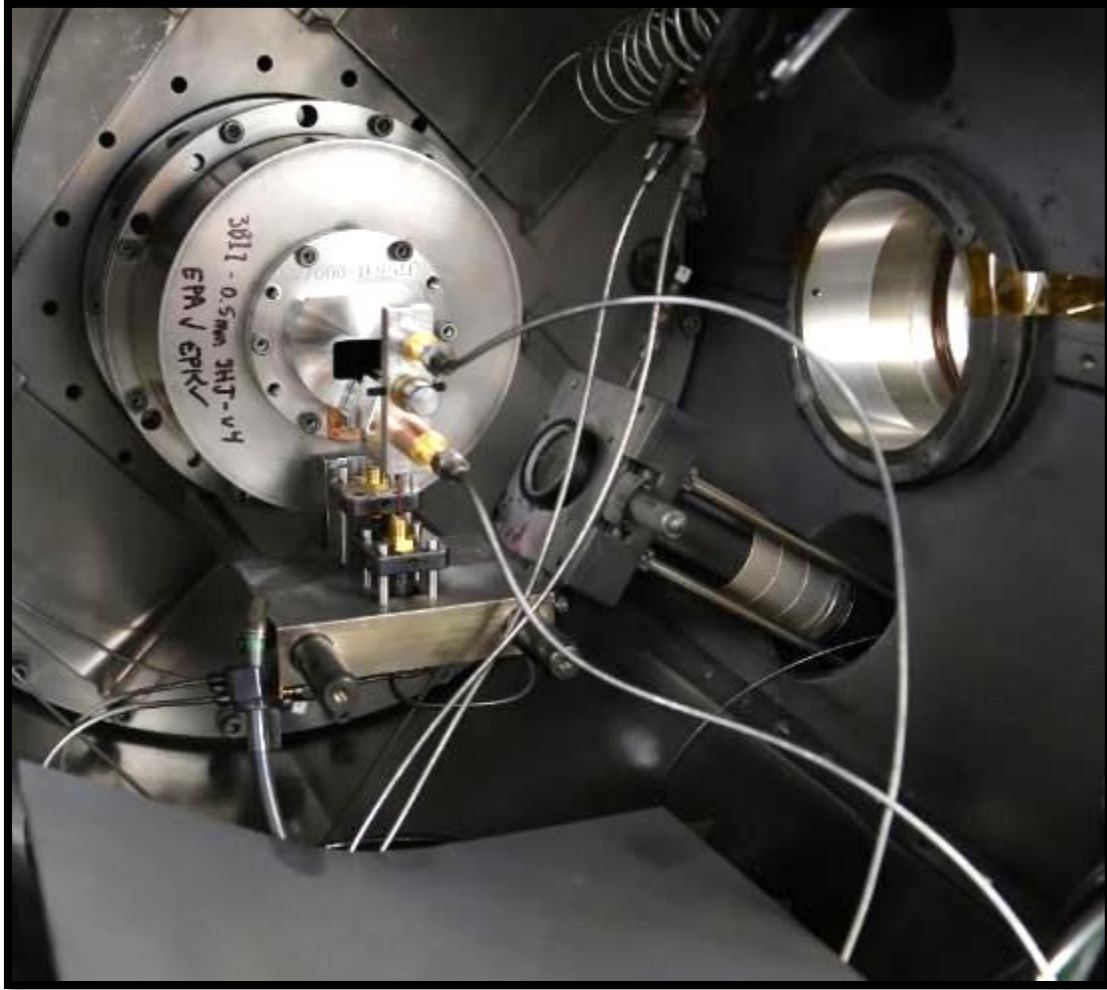


# Summary and Next Steps

- **We are seeing a significant impact from *in-situ* plasma cleaning in delaying electrode plasma formation, reducing total density.**
  - Gated imaging shows 3-5X reduction in observed emission intensity
  - Time-resolved APDs report 12-15 ns delay in electrode turn-on (640 +/- 5nm)
  - Cleaned experimental hardware displays characteristics of delayed impedance collapse within the load region.
  - **To our knowledge, this data is the first of its kind**
- **We have much work to do with this experimental platform**
  - Quantify delays in electrode turn on, load dynamic impedance, apparent closure velocities
  - Utilize spectrally resolved diagnostics to quantify plasma densities and constituent species
- **We have much work to do with the plasma discharge cleaning protocol**
  - Quantify, optimize contaminant removal rates as a function of canonical AK gap
  - Develop a protocol (varying backfill pressures, species, excitation power) that optimally cleans the Z Machine load hardware



## Questions?



Like the Z Machine, Mykonos experimental hardware has a lifetime of one shot.



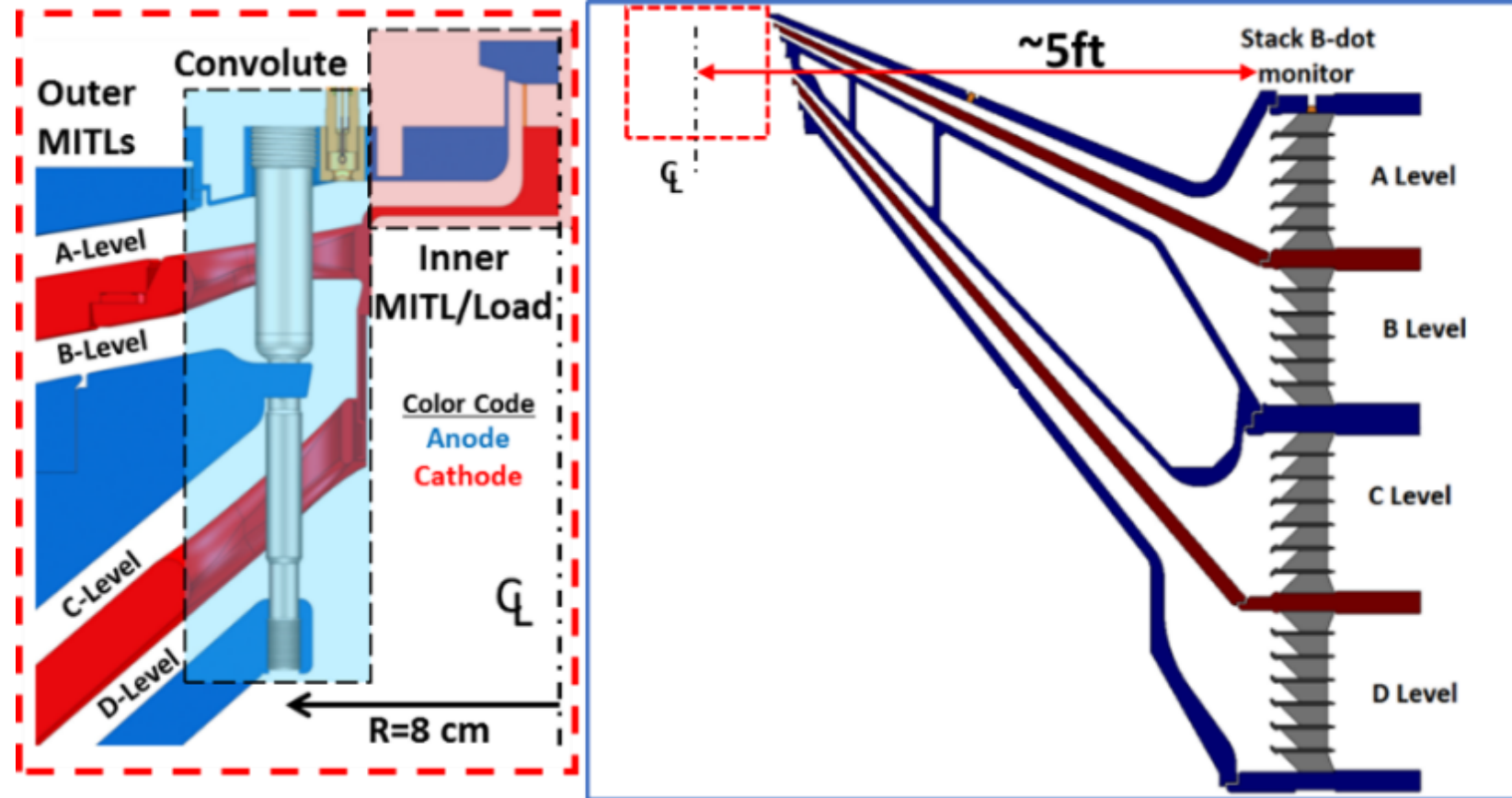
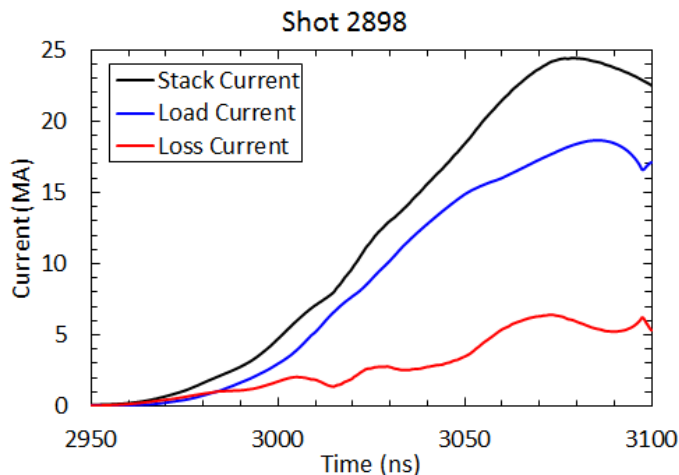
# Backup

# Z delivers up to 27MA to well-matched HEDP targets, but some loads can lose 5-6 MA

## Current loss negatively impacts all Z experiments

- Reliable, achievable pressure profiles in dynamic material properties
- Radiated power for radiation sources
- Fuel compression for inertial confinement fusion

## Current loss occurs in double post-hole convolute, inner MITL



The Z Dual Post-Hole Convoluted (above, left) is used to combine current from four parallel MITLs (above, right) into a single inner MITL that feeds the target. Depending on the load impedance, significant current can be lost before it arrives at the load (left).

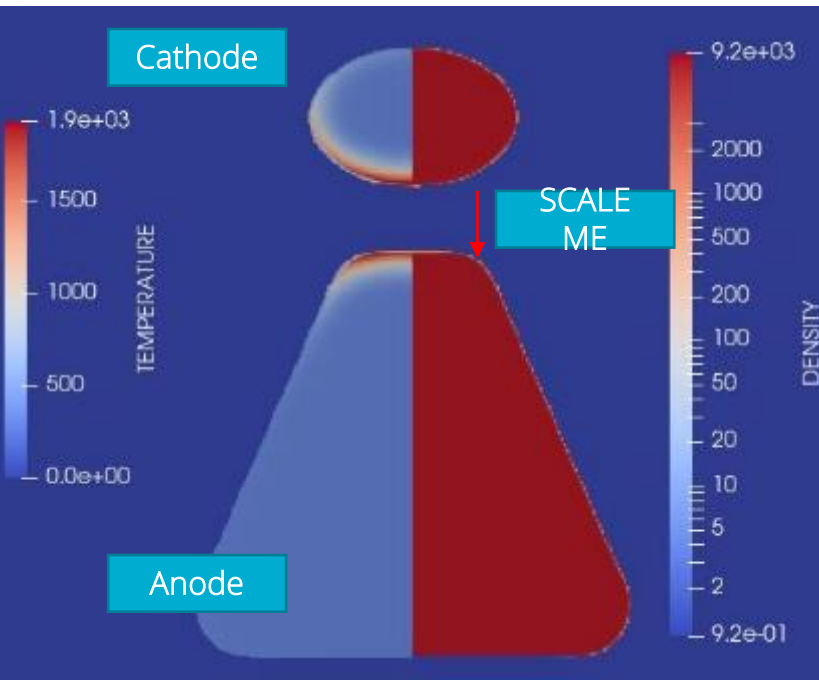


# MHD simulation of geometry shows rapid heating of electrodes, bulk material nearly 1eV at time of machine peak current

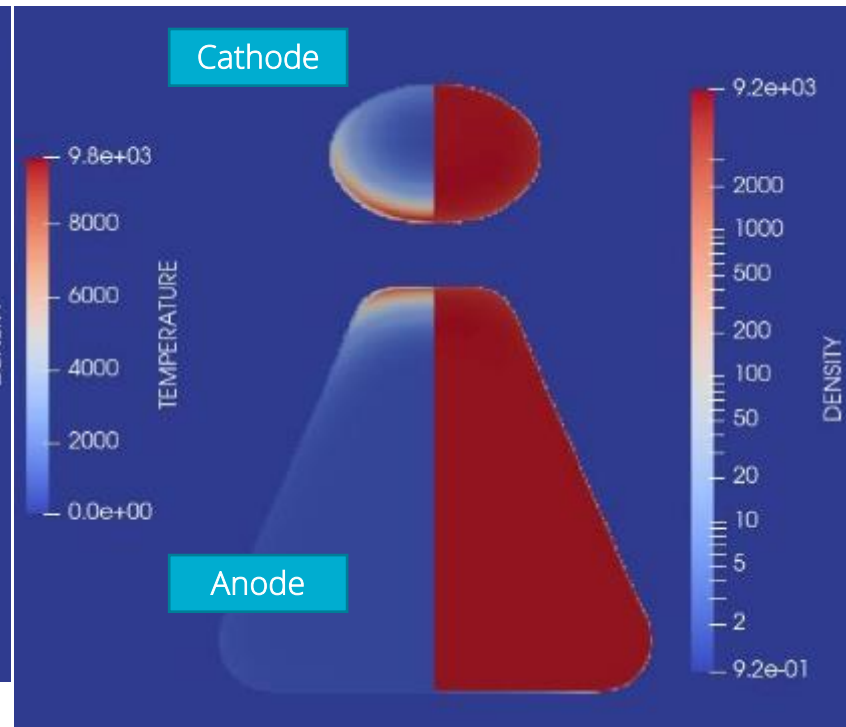
Mykonos accelerator current ~650 kA in 120 ns

Where are we in the Z feed?  
Add slice plane on representation  
geometry to show where?

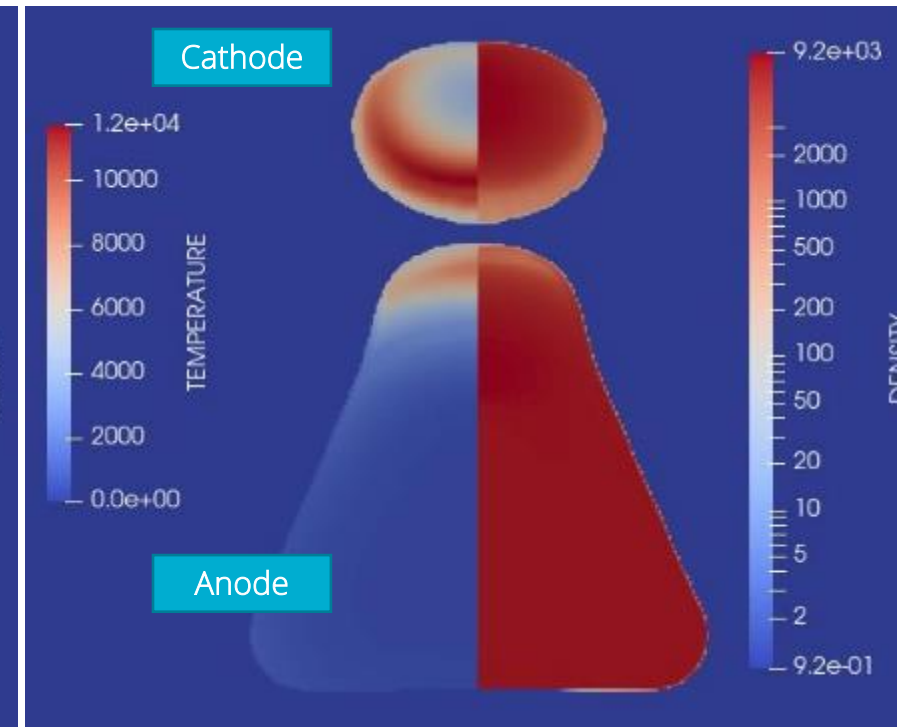
t=50ns



t=100ns



t=200ns



- Desorption temperature ( $>400^{\circ}\text{C}$ ) met within 40ns on each electrode
- Heavy electrode material does not contribute to apparent AK gap closure during current pulse
- Bulk electrode material gets hot - nearly 1eV – providing a backlight for any contaminant plasma
- A cleaned Mykonos experiment should asymptotically approach this condition.

$|B| \sim 250 \text{ T}$  in 0.5mm  
AK gap experiment  
at 100ns



# Particle in Cell calculations in Chicago show plasma dynamics sensitive to AK gap spacing. in general agreement with experiment

